

# Research Article

# A New Measurement Method of Relative Volume Wear Ratio Based on Discharge Debris Composition Analysis in Micro-EDM

# Wei Liu, Zhenyuan Jia, Shangbo Zou, and Xinyi Zheng

School of Mechanical Engineering, Key Laboratory for Precision and Non-Traditional Machining Technology of the Ministry of Education, Dalian University of Technology, 2 Lingong Road, Dalian 116024, China

Correspondence should be addressed to Zhenyuan Jia; jzyxy@dlut.edu.cn

Received 23 December 2013; Accepted 23 March 2014; Published 16 April 2014

Academic Editor: Yunn-Lin Hwang

Copyright © 2014 Wei Liu et al. This is an open access article distributed under the Creative Commons Attribution License, which permits unrestricted use, distribution, and reproduction in any medium, provided the original work is properly cited.

In microelectrical discharge machining (micro-EDM) milling process, due to the unavoidability of electrode wear, selection of electrode with high electrical erosion resistance and accurate electrode compensation is entitled to be conducted to ensure high precision and high quality. The RVWR is used as criterion for electrode wear characteristics and is fundamental to achieve accurate electrode compensation; however, it is hardly measured accurately with conventional methods. In this paper, firstly, the error of RVWR measured by conventional measurement method is analyzed. Thereafter, for accurately measuring RVWR, a new measurement method is proposed based on electrical debris composition analysis. The RVWR of widely used tungsten, molybdenum, and copper electrode in machining different materials is measured, respectively, and the optimum electrode is selected based on the measuring results. Finally, microgrooves on different materials are machined with tungsten electrode, and the experiment results show that the microstructures have good bottom surface profiles, which indicates that the proposed method is effective to precisely measure the RVWR and guarantee accurate electrode compensation in micro-EDM process.

## 1. Introduction

With the continuous development of technologies in various industrial fields quite recently, the demands on product miniaturization are getting increasingly intensive, which stimulates the innovation on new micromachining and precision machining approaches with high machining efficiency and quality. Microelectrical discharge machining (micro-EDM), because of such advantages as contact-less process, no cutting force, low cost, and wide materials suit to fabricate, has been widely applied in the manufacturing of geometrically complex and hard material microstructures. At present, it has been recognized as one of the most valuable techniques for micromachining [1–3].

In three-dimensional (3D) microcavities machining, the fabrication of complex shaped microelectrodes used in diesinking micro-EDM is very difficult and costly [4,5]. With the development of wire electrical discharge grinding (WEDG) technology [6], the micro-EDM milling method with simple-shaped electrode (usually with cylindrical section) is widely adopted [7, 8]. Nevertheless, owing to the principle of EDM, the occurrence of electrode wear is inevitable. And it is much more severe in micro-EDM milling process, due to certain characters of micro-EDM, such as microenergy and high frequency discharge, microsized electrode, large depth-towidth ratio, and hostile processing condition. Insufficient depth of a microgroove/cavity and geometrical inaccuracy of a microstructure are caused by electrode wears in micro-EDM milling process. Thus, in order to enhance machining precision and quality, accurate and effective electrode compensation is entitled to be conducted in micro-EDM milling processes.

Many methods have been presented in solving the problem of electrode wear, such as optimum electrode material selecting and various types of electrode compensation method. Uhlmann and Roehner [9] conducted extensive experimental investigations aiming to decrease the wear of tool electrodes by using boron doped CVD-diamond (B-CVD) and polycrystalline diamond (PCD). Tsai and Masuzawa [10] studied the effects of thermal properties on electrode wear and pointed out that the boiling point of the electrode material plays an important role in the wear mechanism of micro-EDM. Yu et al. [7] and Rajurkar and Yu [11] proposed a uniform wear method (UWM) by scanning the workpiece layer by layer and integrated the electrode compensation and path planning to CAD/CAM system of micro-EDM. Pei et al. [12, 13] presented a fix-length electrode compensation method and studied the effects of RVWR on microgrooves by simulation in micro-EDM milling process. Wang et al. [14] studied the layer-by-layer processing technology of micro-EDM milling process. Bleys et al. [15] presented real-time tool wear sensing and compensation in layer-bylayer EDM milling based on discharge pulse evaluation to estimate electrode wear online with a mathematical model of the sparking frequency. Aligiri et al. [16] also presented a compensation method to estimate material removal volume by counting the number of discharge pulses. To improve machining efficiency, Yan et al. [17] proposed an electrode wear compensation method in micro-EDM using an optical measurement of the tool electrode. However, the proposed compensation approaches [15-17] heavily rely on sophisticated monitoring systems or optical measure systems, which limit their practical applications.

In micro-EDM milling process, the relative volume wear ratio (RVWR) is a vital parameter, which not only is used as criterion for selecting electrode but also is fundamental to achieve accurate compensation in above compensation methods. However, owing to tiny removal of workpiece and electrode, the RVWR can be hardly measured accurately with conventional methods. At present, the RVWR can be measured roughly by machining microholes method or machining microgrooves method, and by calculating the worn volumes of electrodes and workpieces, and the volume wear ratio is obtained as the quotient of them. Although the conventional methods are easy to be conducted, the measurement errors of the geometrical sizes are usually big. Therefore, further experiential works have to be conducted to obtain a relative accurate value, which evidently restrict their practical applicability.

In this paper, the RVWR of machining T2 copper using tungsten electrode is firstly measured by machining microholes method and microgroove machining experiments are conducted to analyze the error of RVWR obtained by conventional method. Then, a new measurement method is presented based on electrical debris composition analysis. Discharge processes on different materials with tungsten, molybdenum, and copper electrode are conducted, and the corresponding RVWR is measured by the proposed method. Finally, the optimum electrode in machining the three kinds of materials is selected according to the measurement results, and microgrooves on these three kinds of materials are machined with tungsten electrode and the measured RVWR.

# 2. The RVWR Measured by Machining Microholes Method

The RVWR is a vital parameter to conduct accurately electrode compensation and can be used as criterion for electrode



FIGURE 1: The photograph of the experimental platform.

wear characteristics which is a reference for selecting an electrode with high electrical erosion resistance. Firstly, the error of the RVWR measured by conventional method is analyzed according to the effects of that on microgrooves.

In order to analyze the effects of RVWR on microgrooves machining, the model of large monolayer thickness and fixlength compensation method [18] are adopted in this paper. The mathematical model is shown in (1). Consider

$$L = \frac{\pi d^2 l_e}{4K_v \left(d + 2\delta\right) l_w \gamma},\tag{1}$$

where *L* is fixed compensation length;  $l_e$  is compensation accuracy; *d* is the diameter of electrode;  $K_v$  is correction volume coefficient which is obtained by extensive experiments;  $\delta$  is side machining gap;  $l_w$  is the machining depth (or the layer thickness);  $\gamma$  is the RVWR. Evidently, when the compensation accuracy  $l_e$ , the machining depth  $l_w$ , and the correction area coefficient  $K_v$  are set beforehand, fixed compensation distance *L* is a function of RVWR  $\gamma$  and the actual bottom surface profile is built based on  $\gamma$ . Therefore, the error of  $\gamma$  cause the error of *L*, which results in overcompensation or undercompensation of microgrooves.

2.1. Experimental Condition. Machining tests are conducted on our self-established high-precision micro-EDM system, as shown in Figure 1, which has a three-axis linkage function with travel of 110 mm(X) × 110 mm(Y) × 120 mm(Z), *z*-axis linear motor worktable with positioning accuracy of 2  $\mu$ m, an *X*-*Y* axis alternating current servomotor worktable with positioning accuracy of 1.5  $\mu$ m, 0.1  $\mu$ m resolution cooperated with the Renishaw grating, a high-speed rotating spindle, a switch tube microenergy resistor-capacitor (RC) pulse power supply, and a self-established NC milling system. Moreover, KEYENCE VHX-600 digital microscope with 3D geometry measuring function is employed to measure the size and shape of microstructures machined in this paper.

The electrode and workpiece materials are listed as follows: copper, tungsten, and molybdenum with diameter 100  $\mu$ m are selected as electrode and 3003 aluminium alloy, #45 steel, and T2 copper are used as workpiece. Moreover, the processing parameters setup is shown in Table 1.

TABLE 1: Discharge parameters setup.

Processing parameters	Work medium	Machining polarity	Open voltage <i>U</i> /V	Peak current <i>I</i> /A	Pulse width $T_{\rm on}/\mu$ s	Interpulse $T_{\rm off}/\mu { m s}$	Capacity C/pF	Electrode rotate speed <i>r</i> /min
Setup	Deionized water	Positive	250	0.88	25	25	1000	2000

The dielectric strength of deionized water is 16 MO  $\cdot cm.$ 

2.2. Error Analysis of the RVWR Measured by Conventional Method. To validate the effects of RVWR on microgrooves machining, microgrooves on T2 copper materials are machined using tungsten electrode with  $\lambda$  obtained by microgrooves machining method. The correlation parameters are shown in Table 2.

Where  $K_v = K_s \cdot K_d$ ,  $K_c$  is area coefficient and  $K_d$  is depth coefficient, and they are estimated by extensive experiments according to [18]. The RVWR of machining T2 copper using tungsten electrode is first measured by machining microholes method, with specific procedure as follows.

- (1) Machining *n* micro-through-holes continuously with the electrode diameter of *d*.
- (2) Measuring these through-holes' radius of entrance and exit, which are indicated as  $r_{1i}$  and  $r_{2i}$ , respectively.
- (3) Measuring the electrode wear length *l* with machine tool's electric contacting function.
- (4) Calculating the RVWR  $\lambda$  by (2).

Consider

$$\lambda = \frac{V_E}{V_W} = \frac{\pi d^2 l}{\sum_{i=1}^n \pi ((r_{1i} + r_{2i})/2)^2 h},$$
 (2)

where  $V_E$  is the wear volume of the electrode;  $V_W$  is the wear volume of workpiece; *h* is the depth of the through-holes.

In this paper, a tungsten electrode with diameter  $100 \,\mu\text{m}$  is used to machine 13 through-holes on 0.3 mm thickness T2 copper workpiece. Consequently, the calculated value of RVWR is 0.028.

Under the condition  $\lambda_1 = 0.028$ , an 8 mm long microgroove is machined based on large monolayer and fixlength compensation method. The micrograph and depth variation of microgroove are shown in Figure 2.

As shown in Figure 2, the depth of microgroove increases along with the machining distances. When the machining distance is about 2 mm, the depth reaches about 61  $\mu$ m which is about 20% deeper than designed. It is caused by the problem that the RVWR measured by microholes method is greater than the actual value. Obviously, the error of the RVWR measured by machining microholes method is big, and the reasons are analyzed as follows.

 Electrode end wear is considered merely in electrode length measurement. However, electrode side wear is serious in machining microholes method. The measurement errors of the geometrical sizes are usually large.

TABLE 2: Compensation parameters setup.

Compensation accuracy $l_e/\mu$ m	Machining gap δ/μm	Machining depth $l_w/\mu m$	Correction area coefficient $K_v$
2.5	32	50	0.835

(2) There are nonignorable errors in electrode wear length measured by electrical contacting function, due to the measuring principle and the repositioning precision of machine tools.

The direct effect of RVWR on microgroove machining is the variation of depth. The microgroove is machined with overcut, when  $\lambda$  is greater than the actual value; conversely, the microgroove is machined with undercut, when  $\lambda$  is less than the actual value [16]. Thus, the microgroove is machined precisely only when  $\lambda$  is equal to the actual value, and the RVWR can be validated according to the accuracy of depth of machined microgroove. In addition, the RVWR measured by machining microholes method is not accurate, and experimental correction by extensive experiments has to be conducted to achieve a relative accurate value. Therefore, a new RVWR measurement method is proposed in Section 2.

# 3. A New Measurement Method of RVWR Based on Electrical Debris Composition Analysis

In micro-EDM process, electrical debris, which is composed of electrode, workpiece, and working medium elements, is thrown into the working fluid, forming globular microparticles. Only a tiny part of electrical debris adheres to the surface of electrode and workpiece, forming cladding layer [19, 20]. Moreover, despite whatever chemical reaction (such as oxidation and carbonization) during machining process, the total amount of metallic elements in electrical debris are always equal to that in the dissipative electrode and workpiece according to the law of conservation of mass; that is, the quality ratio of electrode element and workpiece element in electrical debris is equal to that of the dissipative electrode and workpiece. Once the proportions of major elements in the debris are measured, the RVWR can be calculated based on the composition and density of electrode and workpiece. Therefore, a new measurement method of RVWR based on debris composition analysis is proposed in this paper. The major measurement steps of RVWR based on debris composition analysis are as follows.



FIGURE 2: Micrographs of microchannel on copper with overcompensation.

- (1) The content of major components of the chosen electrode and workpiece is firstly measured.
- (2) Machining experiment with the chosen electrode and workpiece material is conducted for a period of time.
- (3) The working fluid is carefully filtered to collect the electrical debris.
- (4) The collected electrical debris is put into the vacuum drying oven and then dried for about 2 hours.
- (5) The proportion of each component of electrode and workpiece materials in the prepared electrical debris powder is measured. Moreover, the measurements are repeated several times (3 times) and averaged, considering that the elements contented in the debris may not be homogeneous.
- (6) The quality wear ratio according to the composition of electrode and workpiece is calculated.
- (7) The RVWR is finally obtained according to the densities of electrode and workpiece.

## 4. RVWR Measurement of Micro-EDM Process

4.1. Material Composition and Measuring Instrument. In this paper, using the parameters of Table 1, discharge machining processes on 3003 aluminium alloy, #45 steel, and T2 copper materials are firstly machined by tungsten electrode, respectively, and the corresponding electrical debris is gathered and dried to make specimen. Moreover, EPMA-1600 electron probe microanalyzer (Shimadzu Corporation), as shown in Figure 3, is employed to gain the mass fraction, and then the RVWR is calculated according to the density of electrode and workpiece. In addition, to select the optimum electrode in machining these three materials, the same experiments are repeated by molybdenum and copper electrode.



FIGURE 3: The photograph of EPMA-1600.

The composition and density of three kinds of workpiece materials are shown in Table 3. According to the  $\lambda \cdot \theta \cdot \rho$  theory [21], the thermal conductivity, melting point, and electrical resistivity are the main factors which influence the corrosion stability of electrode. The physical properties of electrode materials are shown in Table 4.

#### 4.2. RVWR Measurement

4.2.1. Tungsten Electrode. The major element contents of the electrical debris are shown in Figure 4 and the detailed analysis results of the electrical debris are shown in Table 5, when tungsten electrode is used to machine 3003 aluminium alloy, T2 copper, and #45 steel. As shown in Table 5, the tungsten electrode wear is very small, when it is used to machine the three kinds of workpiece materials.

*4.2.2. Molybdenum Electrode.* The major element contents of the electrical debris are shown in Figure 5 and the detailed analysis results of the electrical debris are shown in Table 6,



FIGURE 4: Composition of discharge debris produced by tungsten electrode machining different workpieces.

Numbe	r Workpiece	Composition	Density g/cm <sup>3</sup>
1	3003 aluminium alloy	Si = 0.6%; Fe = 0.7%; Cu = 0.05~0.2%; Mn = 1.0~1.5%	2.7
2	T2 copper	Cu + Ag = 99.9%; S = 0.005%; Pb = 0.005%; Fe = 0.005%; As = 0.002%; Sb = 0.002%; Bi = 0.001%	8.46
3	#45 steel	$C = 0.42 \sim 0.5\%;  Si = 0.17 \sim 0.37\%;  Mn = 0.5 \sim 0.8\%;  Cr \le 0.25\%;  Ni \le 0.30\%;  Cu \le 0.25\%$	7.85

TABLE 3: Composition and density of three workpiece materials.

when molybdenum electrode is used to machine 3003 aluminium alloy, T2 copper, and #45 steel. As shown in Table 6, the wear of molybdenum electrode machining T2 copper is very small and even less than that of tungsten electrode; however, the wear of molybdenum electrode machining aluminium alloy is much larger than that of tungsten electrode. The molybdenum electrode wear in machining aluminium alloy is about 9 times greater than that in machining T2 copper. 4.2.3. Copper Electrode. The RVWR cannot be measured, as the major element, Cu, is simultaneously contained in electrode and workpiece, when T2 copper is machined by copper electrode.

The major element contents of the electrical debris are shown in Figure 6 and the detailed analysis results of the electrical debris are shown in Table 7, when copper electrode is used to machine 3003 aluminium alloy and #45 steel. As shown in Table 7, the wear of copper electrode in machining



FIGURE 5: Composition of discharge debris produced by molybdenum electrode machining different workpieces.

TABLE 4: Physical properties of three different electrodes.

Electrode	Tungsten	Molybdenum	Copper	
Density $\rho_0/(g/cm^3)$	19.35	10.2	8.7	
Thermal conductivity $\lambda/(W/mK)$	163.3	138	401	
Melting point $\theta/(K)$	3643	2890	1356	
Electrical resistivity $\rho/(\Omega cm)$	5.65 <i>E</i> – 06	5.70 <i>E</i> – 06	1.70 <i>E</i> – 06	
$\lambda \cdot \theta \cdot \rho / (W\Omega)$	0.03361	0.0227	0.0092	

these two kinds of workpiece materials is larger than that of tungsten electrode, and the copper electrode wear in machining #45 steel is about 6 times greater than that in machining aluminium alloy. When the major elements of electrical debris are simultaneously contained in electrode and workpiece, by the proposed method, the RVWR cannot be measured accurately. However, in practical applications, it is uncommon that the major elements are simultaneously contained in electrode and workpiece, for instance, copper electrode used to machine copper alloy materials is scarcely adopted. Therefore, the proposed method is an effective and accurate method to measure the RVWR of most electrodes in machining different workpieces under complex processing condition.

4.3. *Experimental Results Analysis.* In micro-EDM milling process, in order to avoid frequent compensation and achieve better size and shape accuracy, it is desirable that the electrode with high electrical erosion resistance can be employed effectively, which means that the machined distance L should be as



FIGURE 6: Composition of discharge debris produced by copper electrode machining different workpieces.

TABLE 5: Results	of discharge	debris com	position ana	lysis.
	<i>(</i> )			

Number	Electrode workpiece	Testing element	Crystalline types	Content in discharge debris (wt%)	Mass ratio	Volume ratio
1	Tungstan aluminium allow	W	PET	10.643	0.230	0.032
	Tungsten-atunninum anoy	Al	RAP	46.319	0.230	
2	Tungsten_#15 steel	W	PET	6.2450	0.067	0.027
	Tuligstell-#45 steel	Fe	LIF	93.755	0.007	
3	tungsten T2 copper	W	PET	4.2780	0.045	0.020
5	tungsten-12 copper	Cu	LIF	95.713	0.045	0.020

TABLE 6: Results of discharge debris composition analysis.

Number	Electrode workpiece	Testing element	Crystalline types	Content in discharge debris (wt%)	Mass ratio	Volume ratio
4	Molybdenum #45 steel	Мо	PET	5.729	0.064	0.049
	Worybachani-#45 steel	Fe	LIF	89.861	0.004	
5	Molyhdonum aluminium alloy	Мо	PET	17.262	0.421	0.112
	Mory Duenum-aluminium anoy	Al	RAP	40.971	0.421	
6	Malubdanum T2 Connar	Mo	PET	1.162	0.014	0.012
0	Morybaenum-12 Copper	Cu	LIF	80.553	0.014	0.012

TABLE 7: Results of discharge debris composition analysis.

Number	Electrode workpiece	Testing element	Crystalline types	Content in discharge debris (wt%)	Mass ratio	Volume ratio
7	Coppor aluminium allow	Cu	LIF	10.618	0.120	0.040
	Copper-aruminium anoy	Al	RAP	82.393	0.129	
8	Copper #45 steel	Cu	LIF	21.257	0.270	0.244
0	Copper-#45 steel	Fe	LIF	78.743	0.270	0.244



FIGURE 7: RVWR of different electrodes in machining different workpieces.

long as possible in the same compensation accuracy  $l_e$ . In this case, the length of the electrode decreases most slowly and the bottom surface profile can be a gentle slope. Therefore, it is an important way to enhance the processing quality and processing efficiency by selecting electrode reasonably in micro-EDM milling process.

In this paper, three kinds of electrode materials, tungsten, molybdenum, and copper, are selected to machine microgrooves on different workpiece materials, and the corresponding RVWR is measured accurately by the proposed method, which provides a reliable basis for both selecting electrode materials reasonably and exactly conducting compensation. The RVWR comparison charts of machining the different materials using the three kinds of electrode are shown in Figure 7.

As shown in Figure 7, from the perspective of reducing electrode wear, the following rules should be followed: tungsten electrode is prior selected, when #45 steel and aluminium alloy materials are machined; owing to tiny electrode wear, when T2 copper is machined, either tungsten electrode or molybdenum electrode can be selected. In other words, the tungsten electrode, which has the highest value of  $\lambda \cdot \theta \cdot \rho$  [21], can be used to machine microgrooves on these three materials with smaller electrode wear.

## 5. Microgrooves Machining Experiments

The proposed method provides a reliable basis for both selecting electrode materials reasonably and exactly conducting compensation with the measured RVWR. In this paper, tungsten electrode as the optimum electrode is selected to machine microstructures on copper, aluminium alloy, and #45 steel, due to its high electrical erosion resistance in machining the three kinds of workpiece materials. The RVWR of tungsten electrode machining T2 copper, aluminium alloy, and #45 steel is 0.020, 0.032, and 0.027, respectively. Moreover, microgrooves on these three kinds of materials are machined based on large monolayer thickness and fix-length compensation method, as shown in Figures 8–10.

5.1. Experiments on T2 Copper. A square wave microgroove on T2 copper is machined by the parameters listed in Table 2. The micrograph of microgroove is shown in Figure 8(a), and its partial enlarged detail is shown in Figure 8(b), and its width and depth variation with the machining distance is shown in Figure 8(c). As shown in Figure 8, the maximum width and depth variations on the overall length are  $3.1 \,\mu\text{m}$  and  $4.7 \,\mu\text{m}$ , respectively, and the microgroove has good uniformity in width and depth.



(a) Micrograph of square wave microgroove

(b) Partial enlarged detail of square wave microgroove



(c) Width and depth variation of square wave microgroove with machining distance

FIGURE 8: Square wave microgroove on T2 copper workpiece.

Correction

area

coefficient  $K_{\nu}$ 

0.765

TABLE 8: Compensation parameters.

Side machining

gap δ/um

65

Compensation

accuracy  $l_{\rho}/\text{um}$ 

2.5

Machining

depth

 $l_{m}/\text{um}$ 

50

Compensation accuracy <i>l<sub>e</sub></i> /um	Side machining gap δ/um	Machining depth $l_w/um$	Correction area coefficient $K_v$
2.5	45	50	0.810

5.2. Experiments on Aluminium Alloy. A short microgroove with 600  $\mu$ m length on aluminium alloy is machined by the parameters listed in Table 8. The micrograph of short microgroove is shown in Figure 9(a) and its 3D topography with bottom profile is shown in Figure 9(b). Figure 9 indicates that the maximum depth of the microgroove is 50.4  $\mu$ m, and the microgroove has good bottom surface profiles.

5.3. Experiments on #45 Steel. Two curve microgrooves are machined on #45 steel by the parameters listed in Table 9. The micrograph of machined curve microgrooves is shown in Figure 10(a), and its 3D topography of upper

groove is shown in Figure 10(b), and width and depth variation with machining distance is shown in Figure 10(c). As shown in Figure 10, depth variation on about 500  $\mu$ m long range is 3.8  $\mu$ m, and the maximum width and depth variations on the overall length are 3.5  $\mu$ m and 5.3  $\mu$ m, respectively, and the curve microgroove has good bottom surface profiles.

As shown in Figures 8–10, the microgrooves and structure have good bottom surface profiles, which indicate that the proposed method in the paper can effectively and accurately measure the RVWR of most electrodes in machining different materials.

 TABLE 9: Compensation parameters.



(a) Micrograph of short microgroove

(b) 3D topography and bottom profile

FIGURE 9: Micrograph of short microgroove on aluminium alloy.



FIGURE 10: Curve microgrooves on #45 steel.

## 6. Conclusion

In this paper, in microgrooves EDM, experimental results on electrode compensation show that the RVWR obtained by conventional measurement method is inaccurate and can result in variation of groove depth. Then, based on electrical debris composition analysis, a new RVWR measurement method is proposed, which can be applicable to different electrodes machining different workpiece materials without simplifying the processing environment. The RVWR of machining T2 copper, aluminum alloy, and #45 steel using the electrodes of tungsten, molybdenum, and copper are measured. Selection of electrode with high electrical erosion resistance and accurate electrode compensation experiments are conducted according to the measuring results. Experiments on microgrooves show that the machined microstructures have good bottom surface profiles, which indicates that the proposed method is an effective way to accurately

measure the RVWR of most electrodes in machining different workpiece materials. This research conclusion can be adopted as a basis in selecting electrode material reasonably and ensuring the accurate compensation in micro-EDM. Further study is suggested to focus on measuring the RVWR of more electrode materials and workpiece materials with plenty of experiments and establishing a database of widely used electrodes in machining different workpiece materials, which can provide an important reference to practical applications.

## **Conflict of Interests**

The authors declare that there is no conflict of interests regarding the publication of this paper.

### Acknowledgments

This paper is supported by the National Natural Science Foundation of China (Grant no. 51005036).

## References

- K. Liu, B. Lauwers, and D. Reynaerts, "Process capabilities of micro-EDM and its applications," *International Journal of Advanced Manufacturing Technology*, vol. 47, no. 1–4, pp. 11–19, 2010.
- [2] D. K. Chung, H. S. Shin, M. S. Park, B. H. Kim, and C. N. Chu, "Recent researches in micro electrical machining," *International Journal of Precision Engineering and Manufacturing*, vol. 12, no. 2, pp. 371–380, 2011.
- [3] J. Fleischer, T. Masuzawa, J. Schmidt, and M. Knoll, "New applications for micro-EDM," *Journal of Materials Processing Technology*, vol. 149, no. 1–3, pp. 246–249, 2004.
- [4] Y.-Y. Hu, D. Zhu, N. S. Qu, Y. B. Zeng, and P. M. Ming, "Fabrication of high-aspect-ratio electrode array by combining UV-LIGA with micro electro-discharge machining," *Microsystem Technologies*, vol. 15, no. 4, pp. 519–525, 2009.
- [5] D. T. Pham, S. S. Dimov, S. Bigot, A. Ivanov, and K. Popov, "Micro-EDM—recent developments and research issues," *Journal of Materials Processing Technology*, vol. 149, no. 1–3, pp. 50– 57, 2004.
- [6] T. Masuzawa, M. Fujino, K. Kobayashi, T. Suzuki, and N. Kinoshita, "Wire electro-discharge grinding for micromachining," *CIRP Annals—Manufacturing Technology*, vol. 34, no. 1, pp. 431–434, 1985.
- [7] Z. Y. Yu, T. Masuzawa, and M. Fujino, "Micro-EDM for threedimensional cavities—development of uniform wear method," *CIRP Annals—Manufacturing Technology*, vol. 47, no. 1, pp. 169– 172, 1998.
- [8] T. Masuzawa and H. K. Tonshoff, "Three-dimensional micromachining by machine tools," *CIRP Annals—Manufacturing Technology*, vol. 46, no. 2, pp. 621–628, 1997.
- [9] E. Uhlmann and M. Roehner, "Investigations on reduction of tool electrode wear in micro-EDM using novel electrode materials," *CIRP Journal of Manufacturing Science and Technology*, vol. 1, no. 2, pp. 92–96, 2008.
- [10] Y.-Y. Tsai and T. Masuzawa, "An index to evaluate the wear resistance of the electrode in micro-EDM," *Journal of Materials Processing Technology*, vol. 149, no. 1–3, pp. 304–309, 2004.

- [11] K. P. Rajurkar and Z. Y. Yu, "3D micro-EDM using CAD/CAM," CIRP Annals—Manufacturing Technology, vol. 49, no. 1, pp. 127– 130, 2000.
- [12] J.-Y. Pei, R. Deng, and D.-J. Hu, "Bottom surface profile of single slot and fix-length compensation method in micro-EDM process," *Journal of Shanghai Jiaotong University*, vol. 43, no. 1, pp. 42–46, 2009.
- [13] J.-L. Xu, J.-G. Li, J.-Y. Pei, and D.-J. Hu, "Effects of relative volume wear ratio on micro-EDM process and its method for measuring," *Journal of Shanghai Jiaotong University*, vol. 43, no. 9, pp. 1508–1511, 2009.
- [14] Z. Wang, W. Zhao, and G. Liu, "Research on laminated removal micro-EDM," *Jixie Gongcheng Xuebao/Chinese Journal* of Mechanical Engineering, vol. 38, no. 2, pp. 22–26, 2002.
- [15] P. Bleys, J.-P. Kruth, and B. Lauwers, "Sensing and compensation of tool wear in milling EDM," *Journal of Materials Processing Technology*, vol. 149, no. 1–3, pp. 139–146, 2004.
- [16] E. Aligiri, S. H. Yeo, and P. C. Tan, "A new tool wear compensation method based on real-time estimation of material removal volume in micro-EDM," *Journal of Materials Processing Technology*, vol. 210, no. 15, pp. 2292–2303, 2010.
- [17] M.-T. Yan, K.-Y. Huang, and C.-Y. Lo, "A study on electrode wear sensing and compensation in Micro-EDM using machine vision system," *International Journal of Advanced Manufacturing Technology*, vol. 42, no. 11-12, pp. 1065–1073, 2009.
- [18] L. X. Zhang, Z. Y. Jia, W. Liu, and L. Wei, "A study of electrode compensation model improvement in microelectrical discharge machining milling based on large monolayer thickness," *Proceedings of the Institution of Mechanical Engineers, Part B: Journal of Engineering Manufacture*, vol. 226, no. 5, pp. 789–802, 2012.
- [19] A. K. Khanra, L. C. Pathak, and M. M. Godkhindi, "Microanalysis of debris formed during electrical discharge machining (EDM)," *Journal of Materials Science*, vol. 42, no. 3, pp. 872–877, 2007.
- [20] Z. Jia, X. Zheng, F. Wang, and W. Liu, "Statistical description of debris particle size distribution in electrical discharge machining," *Chinese Journal of Mechanical Engineering*, vol. 24, no. 1, pp. 67–72, 2011.
- [21] M. Mahardika, T. Tsujimoto, and K. Mitsui, "A new approach on the determination of ease of machining by EDM processes," *International Journal of Machine Tools and Manufacture*, vol. 48, no. 7-8, pp. 746–760, 2008.



Active and Passive Electronic Components International Journal of Antennas and Propagation



Shock and Vibration



Journal of Electrical and Computer Engineering









Advances in **OptoElectronics** 







Advances in Mechanical



Engineering